



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re ap | oplication of: |) |
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| Linda BRALY et al. | | |
| Applic | ation No. 10/002,676 |) |
| Filed: | October 31, 2001 |) |
| For: | METHOD FOR PLANARIZATION ETCH WITH IN-SITU MONITORING BY INTERFEROMETRY PRIOR TO RECESS ETCH |) |

CERTIFICATE OF MAILING

Docket No. LAM2P298

Examiner: W. Powell

Group Art Unit: 1765

Date: January 8, 2004

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 8, 2004.

22313-1430 on <u>january 6, 2004</u>

Diane Schwanbeck

AMENDMENT UNDER 37 C.F.R. § 1.312

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. § 1.312, please amend this application as follows:

The Amendments to the Claims made herein are reflected in the Listing of Claims, which begins on page 2 of this paper.

Applicants' Remarks begin on page 9 of this paper.